

Evaluation of imprint DESI-MS substrates for fungal metabolites analysis.

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Supporting Information

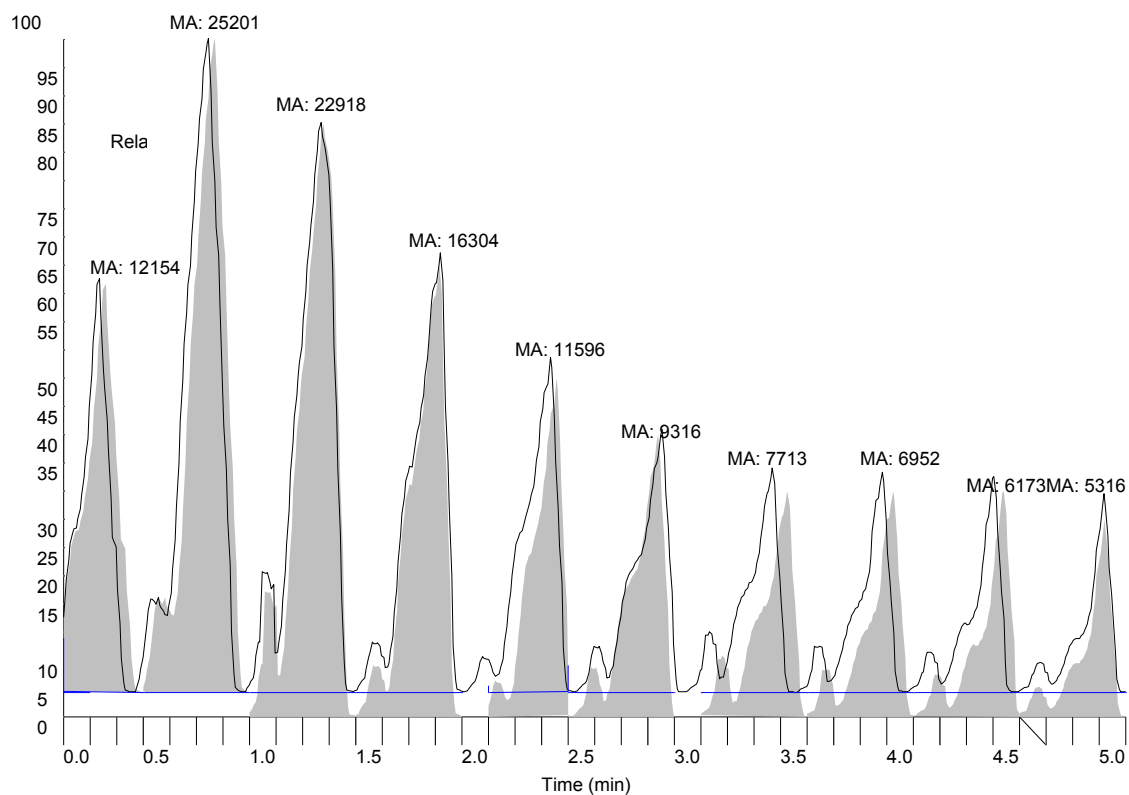


Figure S1: Imprint DESI-MS Extracted chromatogram with highlighted peak area on a meso porous pSi surface . MA=Manual area

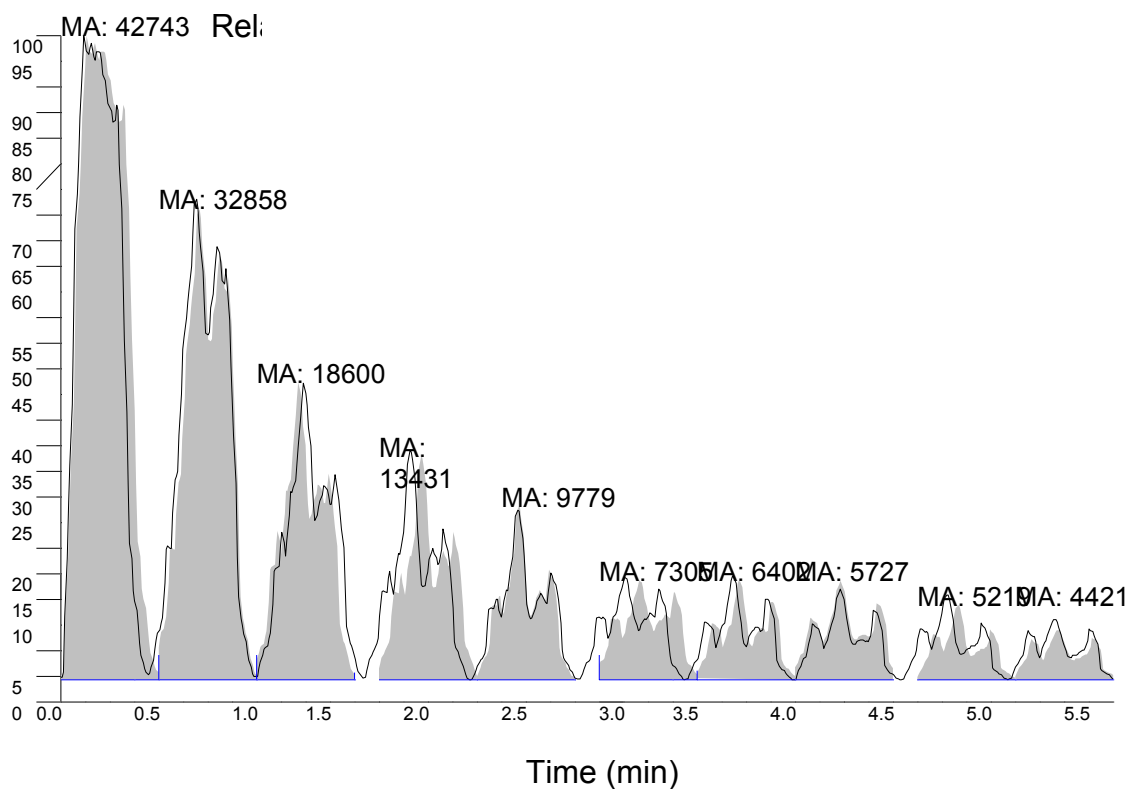


Figure S2: Imprint DESI-MS extracted chromatogram of *T.harzianum* with highlighted peak area on a flat porous surface. MA=Manual area

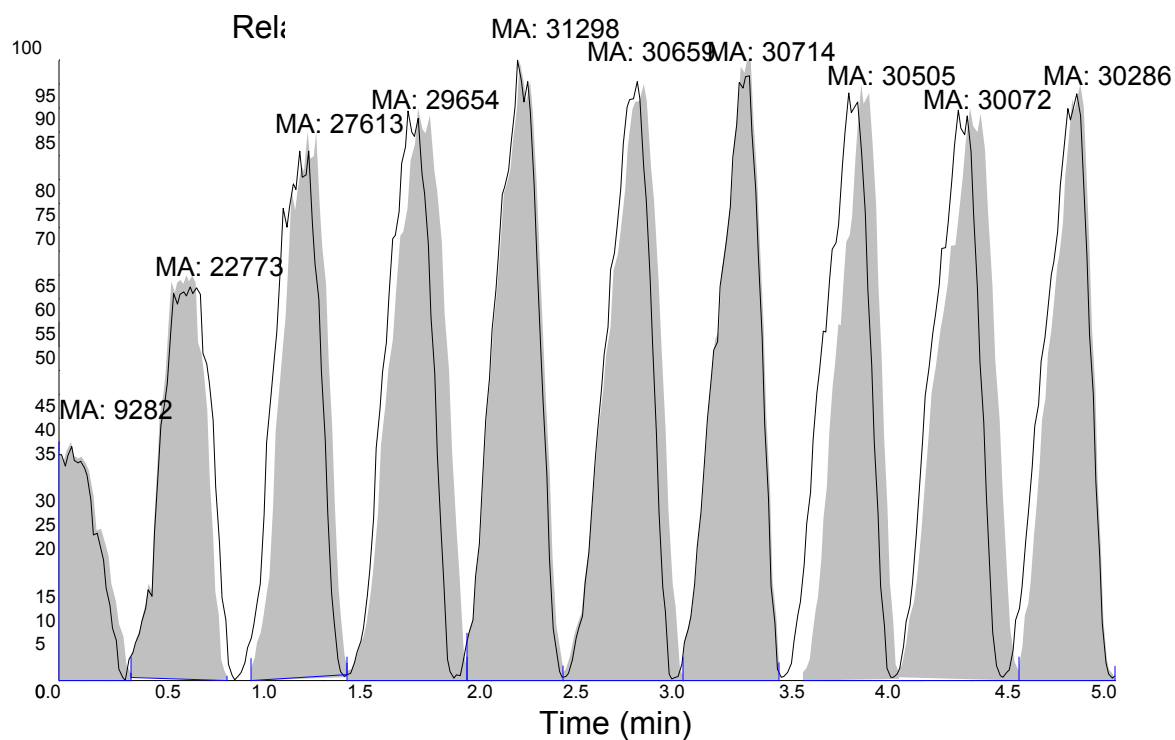


Figure S3: Imprint DESI-MS extracted chromatogram of *T.harzianum* with highlighted peak area on Whatman™ Filter paper . MA=Manual area

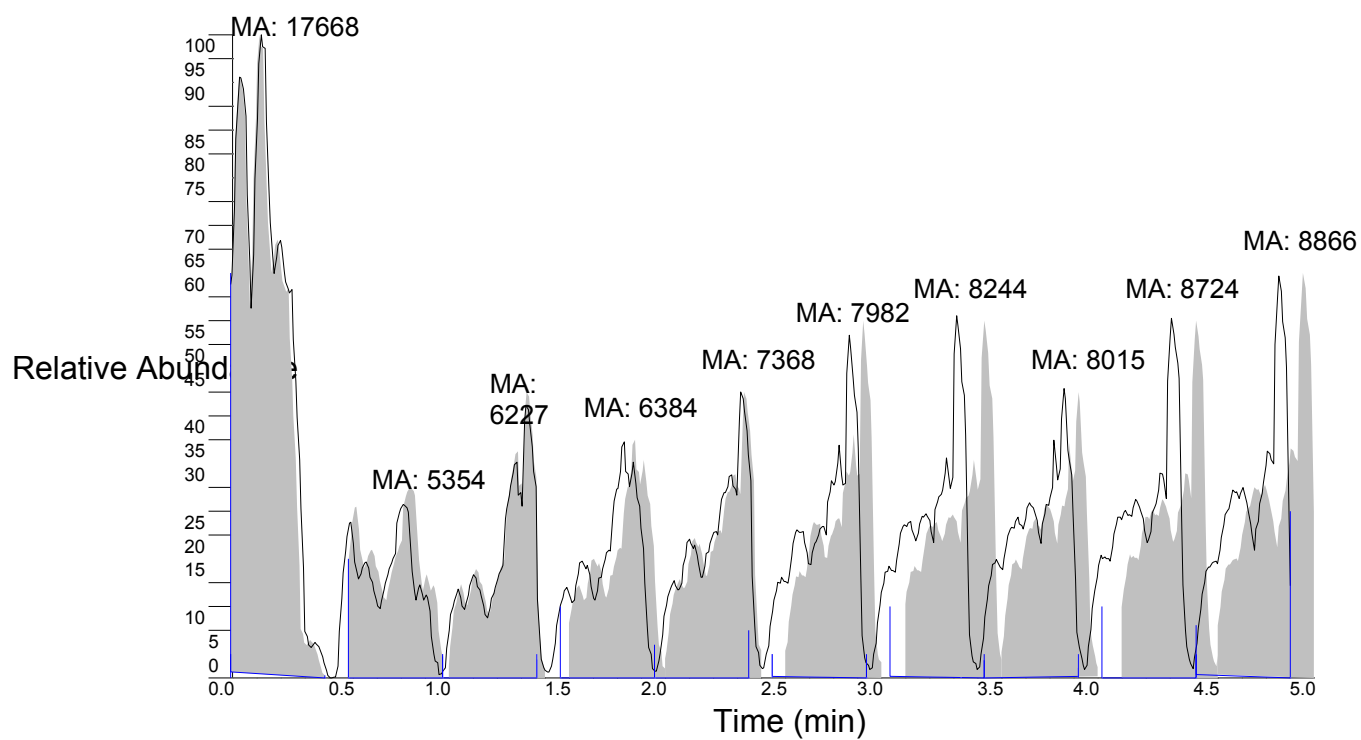


Figure S4: Imprint DESI-MS extracted chromatogram of *T.harzianum* with highlighted peak area on TLC plate. MA=Manual area

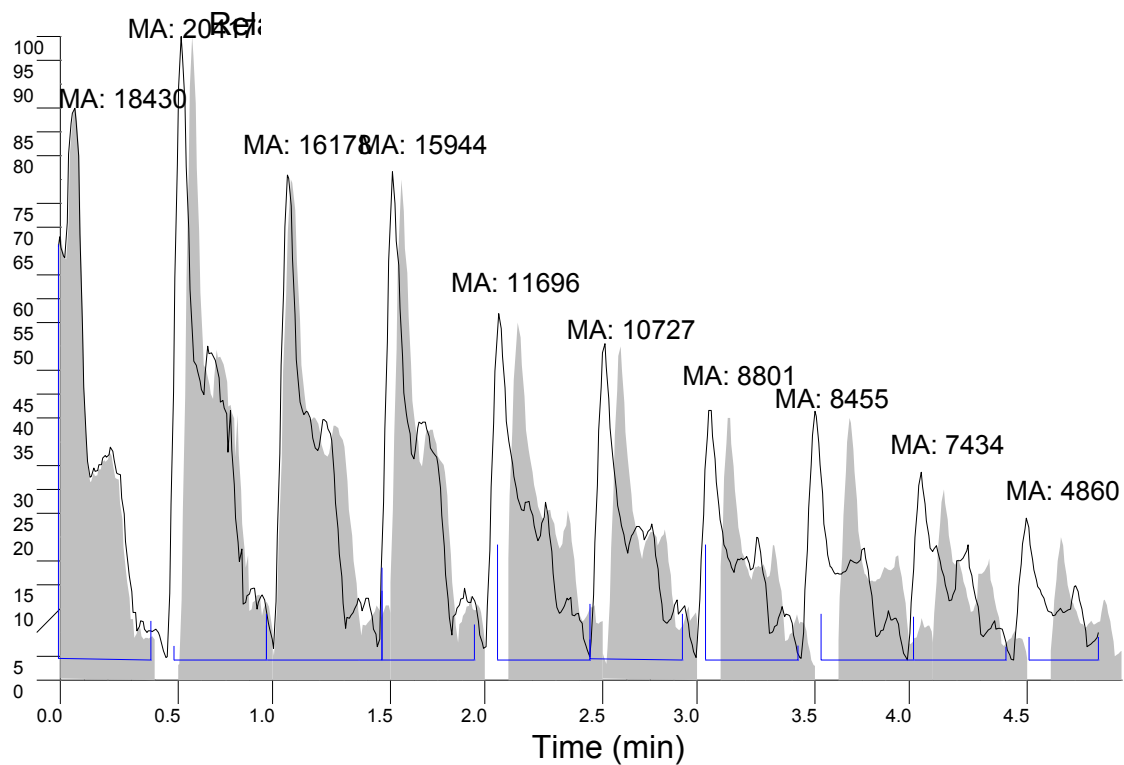


Figure S5: Imprint DESI-MS extracted chromatogram of *T.harzianum* with highlighted peak area on tape surface. MA=Manual area

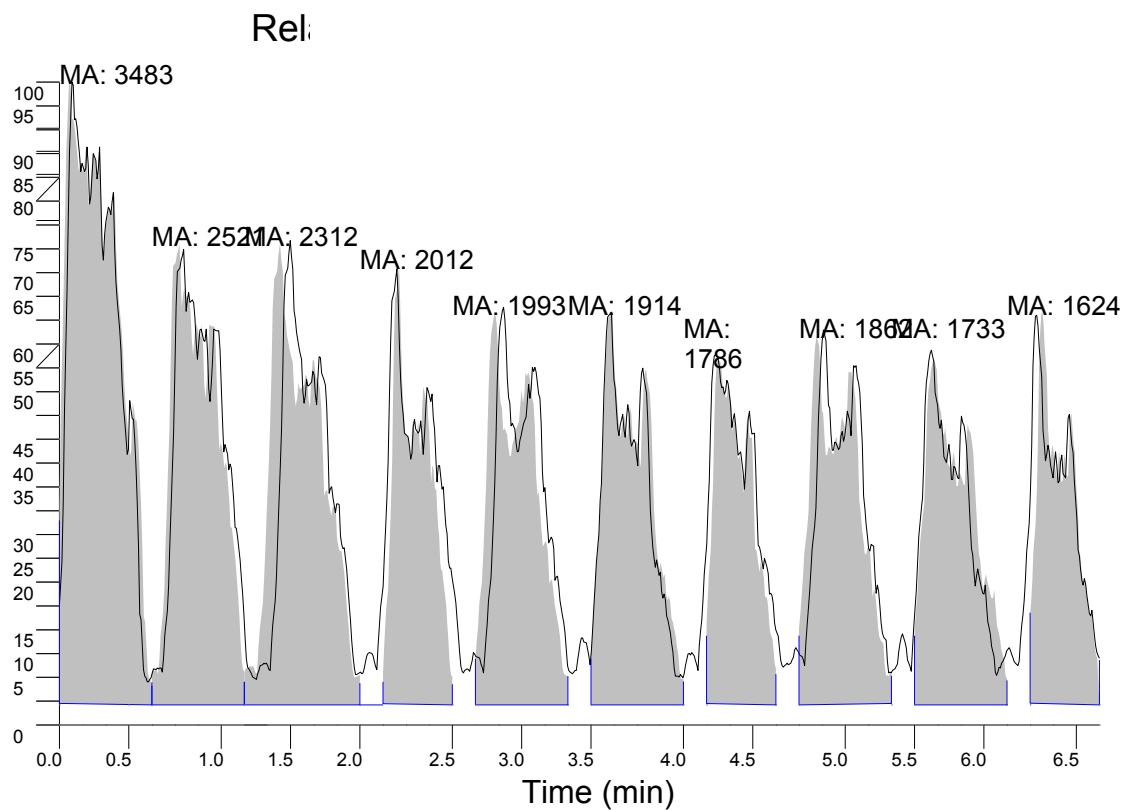


Figure S6: Imprint DESI-MS extracted chromatogram of *T.harzianum* with highlighted peak area on PTFE surface. MA=Manual area

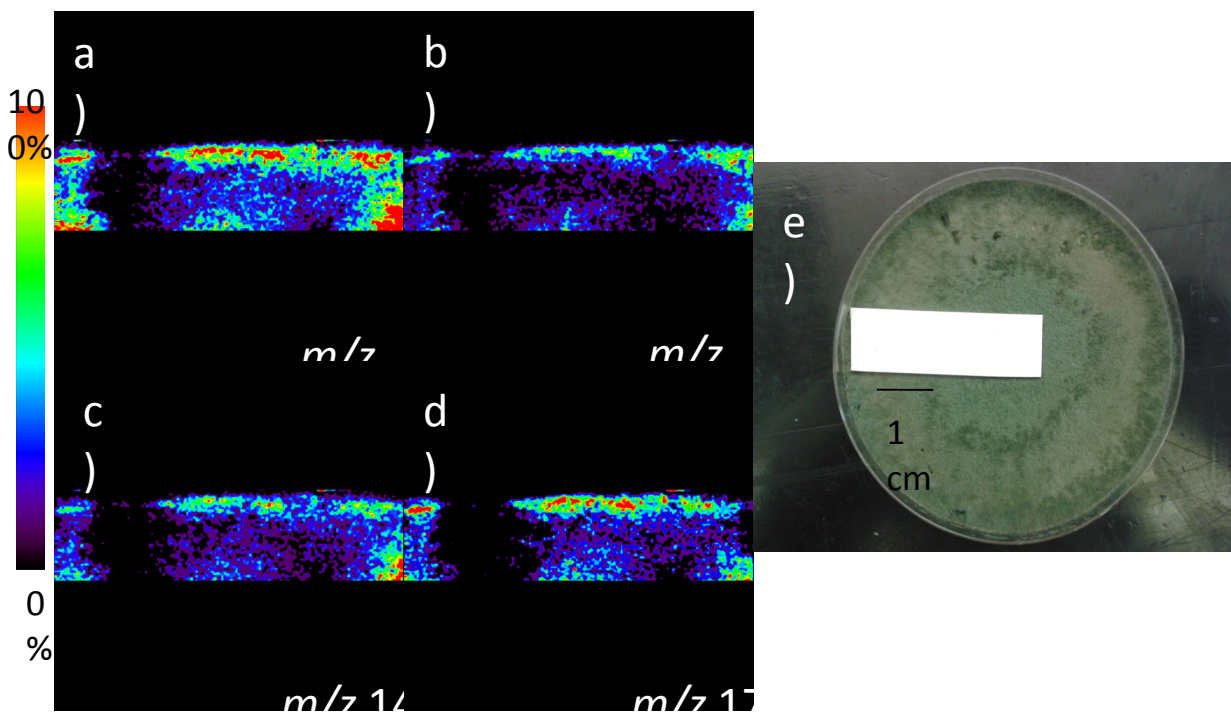


Figure S7: Imprint DESI-MS imaging of *T. Harzanium* on PTFE surface a) Trichotoxin 3 at m/z 882 b) Trichotoxin 4 at m/z 886 c) m/z 1468 d) m/z 1741 e) Optical image of *T. Harzanium* culture grown on a PDA plate during imprinting with a section of PTFE

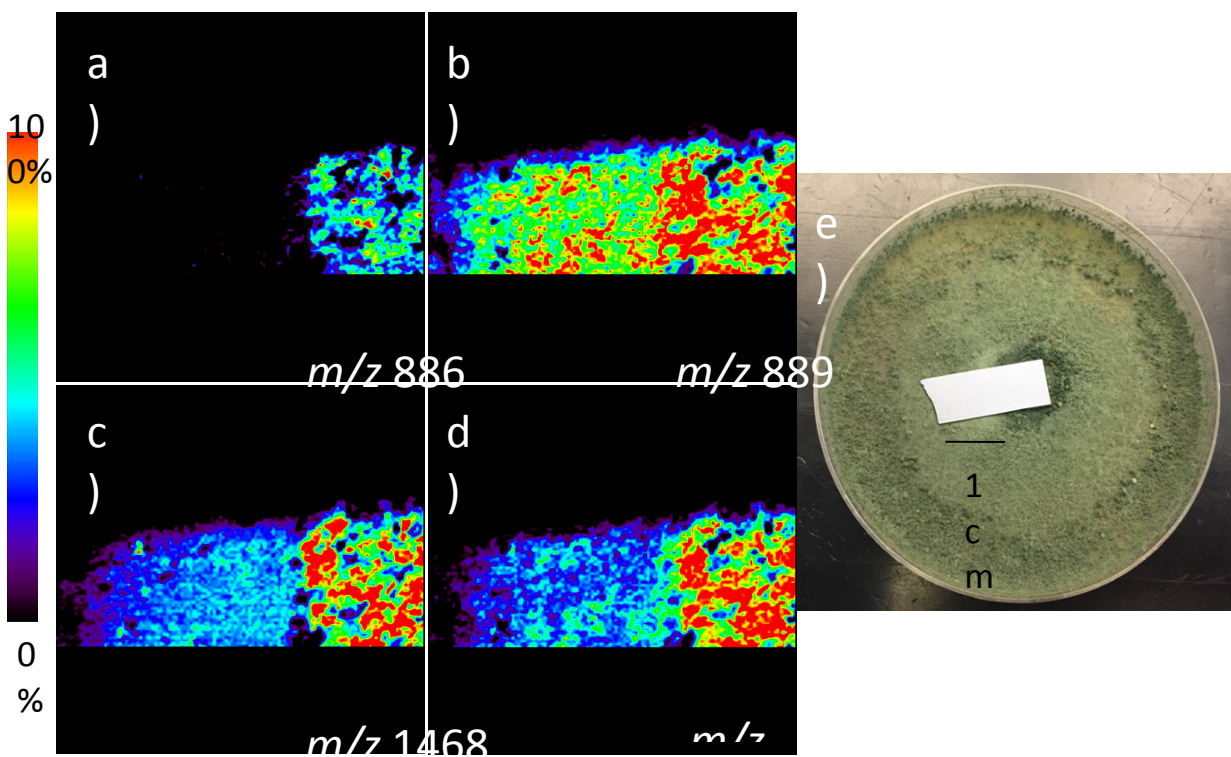


Figure S8: Imprint DESI-MS imaging of *T. Harzanium* on flat Silicon surface a) Trichotoxin 3 at m/z 882 b) Trichotoxin 4 at m/z 886 c) m/z 1468 d) m/z 1741 e) Optical image of *T. Harzanium* culture grown on a PDA plate during imprinting with flat Silicon wafer

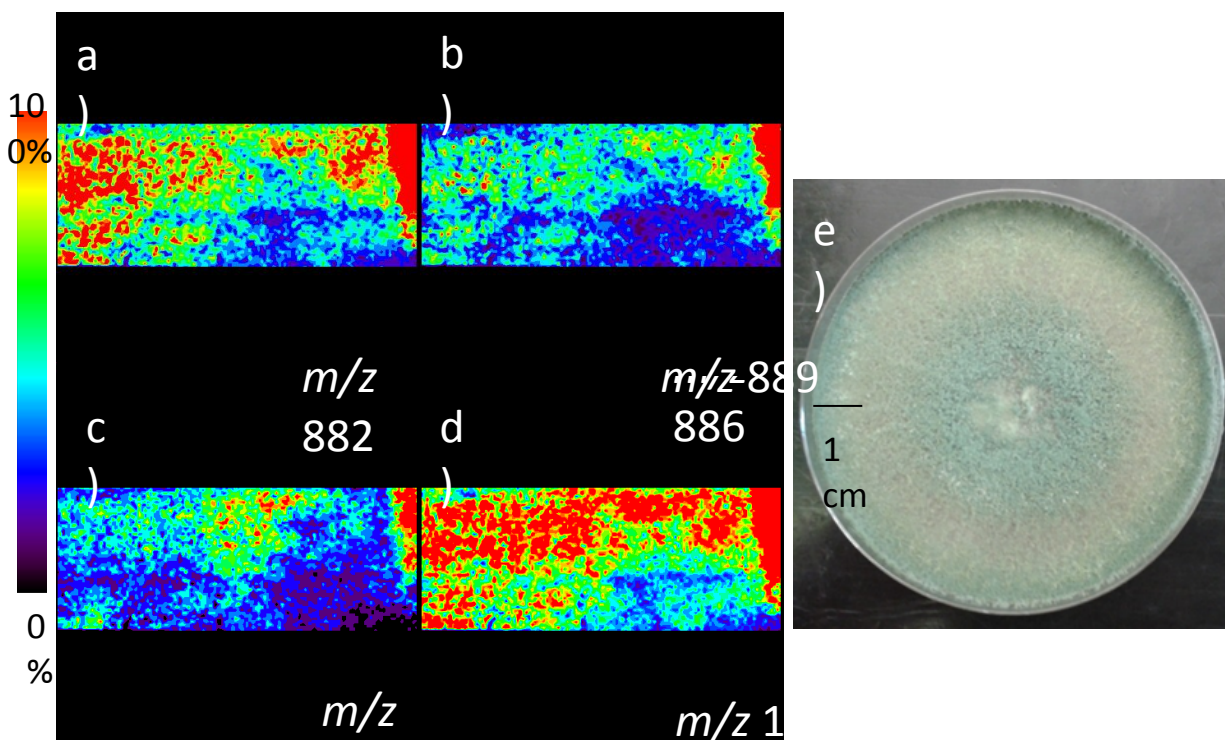


Figure S9: Imprint DESI-MS imaging of *T. Harzanium* on TLC a) Trichotoxin 3 at m/z 882 b) Trichotoxin 4 at m/z 889 c) m/z 1468 d) m/z 1741 e) Optical image of *T. harzanium* culture grown on a PDA